

METHOD AND APPARATUS FOR WASHING AND DRYING PINS IN MICROARRAY SPOTTING INSTRUMENTS

Abstract of the Disclosure

A method and apparatus are provided for washing and drying pins in a microarray spotting instrument. The apparatus includes an array of chambers, each for receiving one of the pins of the spotting instrument. To wash the pins, streams of wash fluid are directed at the pins. To dry the pins, a gas such as air is flowed over pin surfaces.